

Electron Induced Damage in Silicon

-TRIM and TCAS Simulations-

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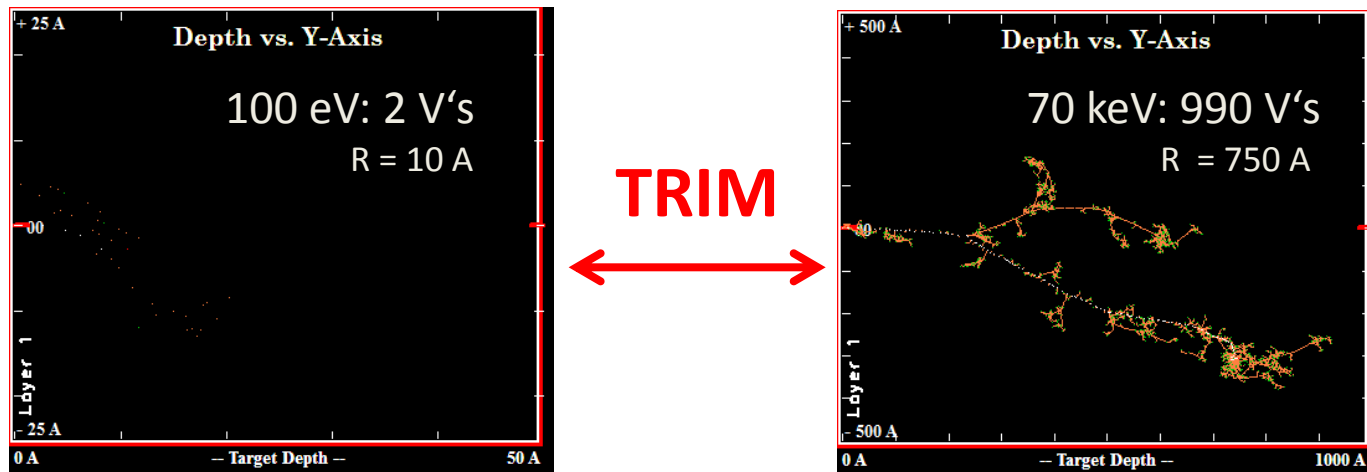
Gregor Kramberger, Jozef Stefan Institute, Ljubljana

Outline:

- **Motivation**
- **Mott-formula and approximations**
- **Recoil-Energy Distributions**
- **Partition Ratio and Damage Function**
- **TRIM and TCAS results**
- **Simulations, Random Walk**
- **Conclusions and Outlook**

Motivation:

- Damage caused by heavy particles (n , p , π) result from a mixture of (a) point and (b) „cluster“ defects
- Electron Irradiation in e.g. an energy range 1-30 MeV could offer an opportunity to correlate exp. results to (a) and (b)
- Maximum Si-recoil energy for **1 MeV** is only 100 eV, for **30 MeV** it is 70 keV, very similar to MeV neutrons!



Mott scattering

Scattering of relativistic electrons on Coulomb potential of point like charges (later on expanded by including screening):

Dirac theory: [Mott, Proc. Royal Soc. A124 \(1929\) and A135 \(1932\)](#)

$(d\sigma/d\Omega)_{Mott} = (d\sigma/d\Omega)_{Ruth} \cdot R_{Mott}$; $(d\sigma/d\Omega)_{Ruth}$ relativistic Rutherford-scattering

$$R_{Mott} = A(E, \theta) \cdot |F|^2 + B(Z, E, \theta) \cdot |G|^2$$

F, G complex functions, expansion with $D_k(\alpha Z, \beta)$ and Legendre Polynoms $P_k(\cos\theta)$

Expansion only conditionally convergent, **exact numerical solution difficult!**

Numerical approximation by [T. Lijian et al: Rad. Phys. Chem. 45, 235 \(1995\)](#):

$$R_{Lijian}(Z, E_k, \theta) = \sum_{j=0}^4 a_j(E_k) \cdot (1 - \cos \theta)^{j/2} \text{ und } a_j(E_k) = \sum_{k=1}^6 d(j, k) \cdot (\beta - \beta^*)^{k-1}$$

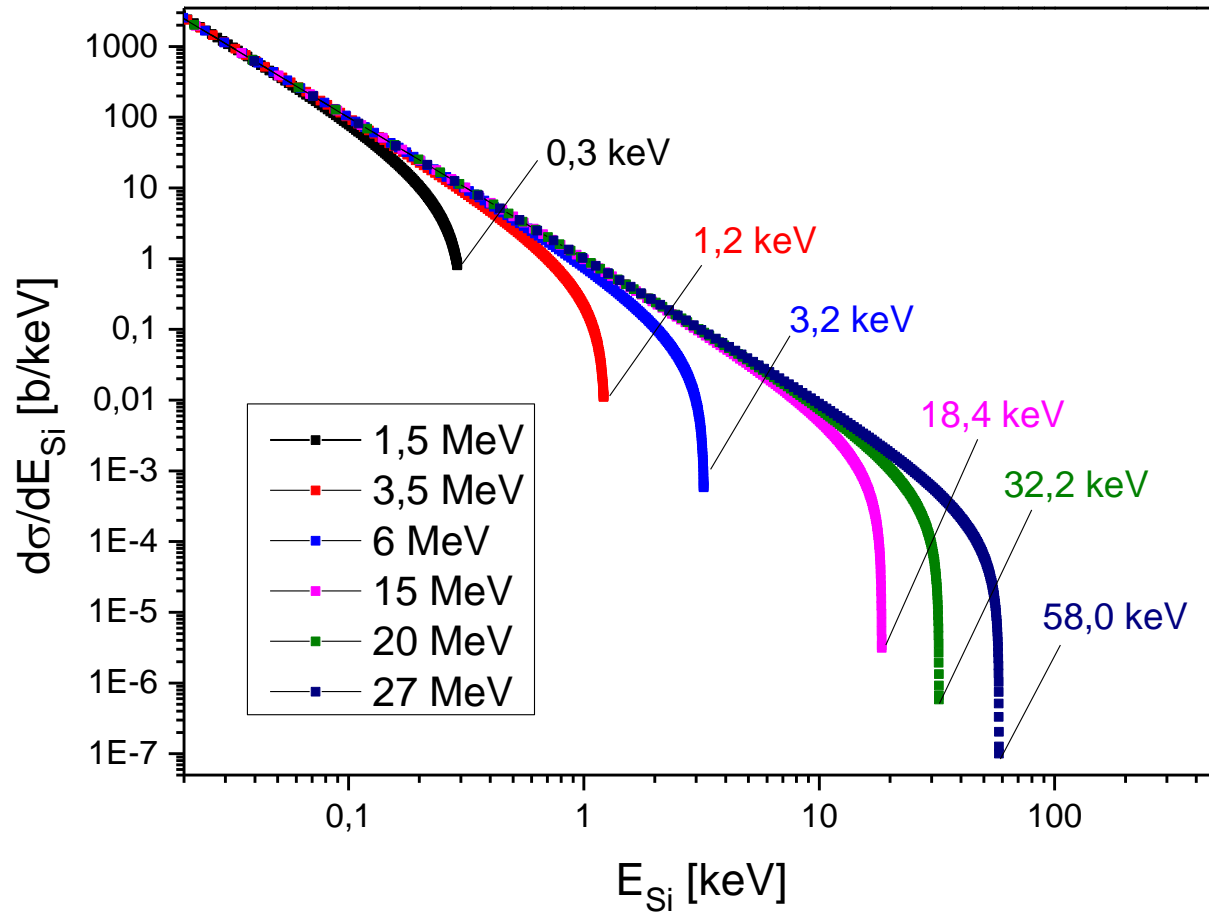
Deviations from exact Mott: < 1% for 30 keV-900 MeV; Z = 1-89

Be aware of simple formula, often found in textbooks: $d\sigma/d\Omega = (d\sigma/d\Omega)_R \cdot (1 - \beta^2 \sin^2 \theta / 2)$

Recent good approach also by: [M.J. Broschini et al, Rad. Phys. Chem. , preprint April 2013](#)

Recoil Energy Distributions

Mott scattering, Lijians approach



Partition Function Q

describes that part of the energy loss which is responsible for NIEL

J. Lindhard et al., *Mat. Fys. Medd. Dan. Vid. Selsk.*, vol 33, pp. 1-42, 1963.

Practical applications: use analytical approximation

M.T. Robinson, *J. Nucl. Materials*, vol.216, pp 1-28, 1994

J. Akkermann and J. Barak, *IEEE Trans. Nucl. Sci.* 53, 6 (2006)

I. Jun et al.; *IEEE Trans Nucl. Sci* 56, 6 (2009)

For Si ions in Si:

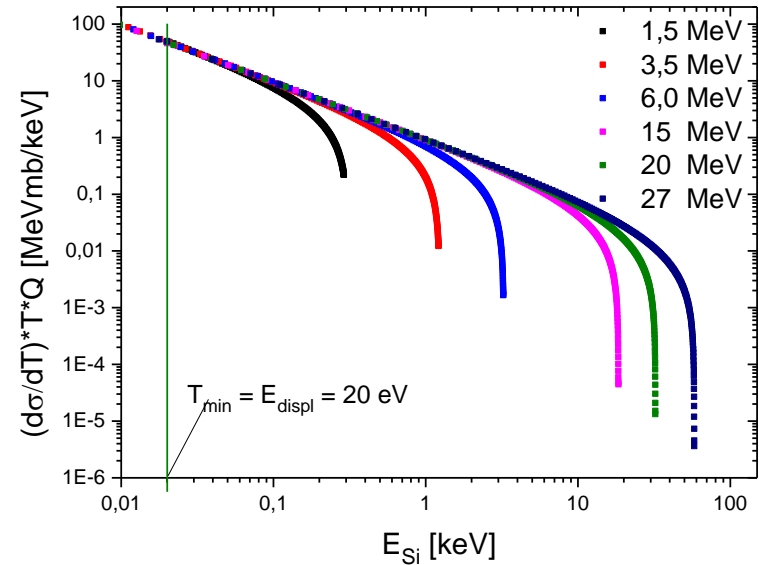
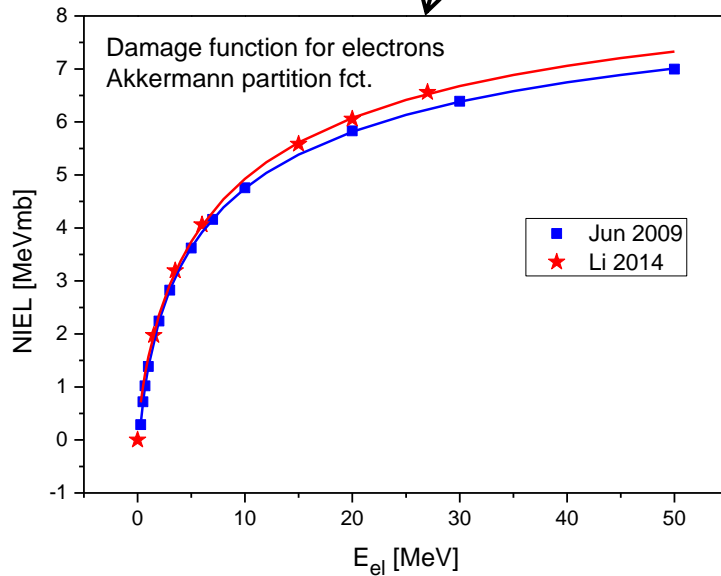
$$Z_1 = Z_2 = 14; M_1 = M_2 = 28$$

$$Q(T) = [1 + k \cdot g(\varepsilon)]^{-1}; k = 0,1463; \varepsilon = T/E_L, T = \text{recoil energy}, E_L = 41,05 \text{ keV}$$

$$g(\varepsilon) = 0,74422\varepsilon + 1,6812\varepsilon^{3/4} + 0,90565\varepsilon^{1/6} \text{ (Jun from Akkermann)}$$

Damage function-1

$$\text{NIEL} = \int_{T_{\min}}^{T_{\max}} \left(\frac{d\sigma}{dT} \right) Q(T) T dT$$



5% difference between present results and Jun,
Jun: with atomic screening in relativ. Rutherford scattering

Monte Carlo Codes for Damage Cascades

TRIM:

James F. Ziegler, IBM

Last update: 2013

- **amorphous material**
- Full damage cascades
- Broad choice of inputs
- graphic design

- Direct 2D graphic output
- No of vacancies
- Output tables: V(ok), **I: ??**

TCAS*

Matthias Posselt, HZDR

Last update: April 2014

- **Single crystal Si <100>**
- Full damage cascades
- Broad choice of inputs
- LINUX by command

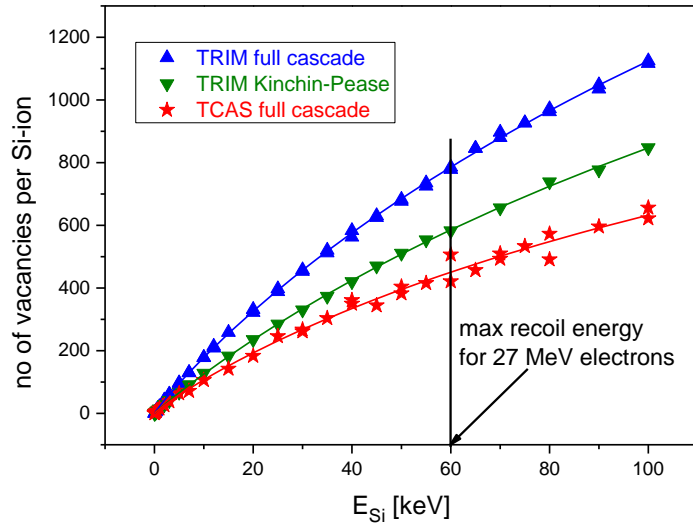
- graphic output included
- **V and I tables**
- **+ Intracasc. recomb.**

!! BCA-code (binary collision approximation), Zero K only !!

* **Many thanks to Matthias Posselt for continuous help**

TRIM and TCAS results – Damage function-2

No of V's (TRIM) resp. V/I's (TCAS) per ion



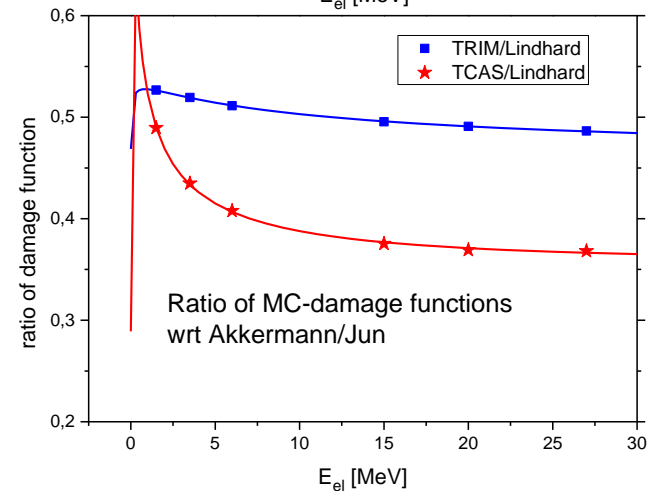
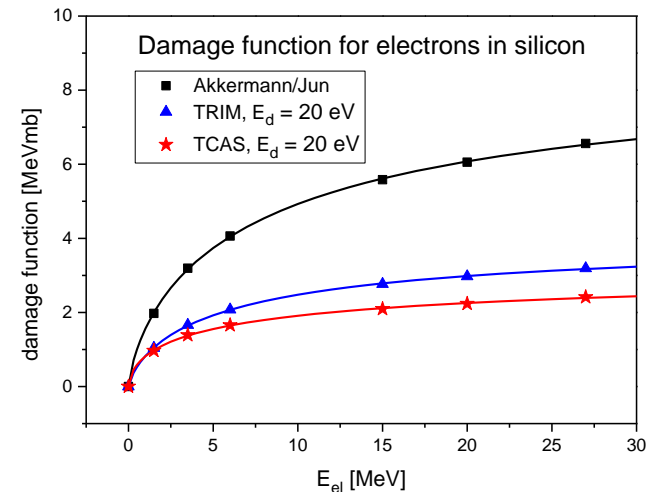
TRIM: $E_d = 20$ eV, average per 100 ions

TCAS: $E_d = 20$ eV, average per 10 ions

TRIM/TCAS = 1,8

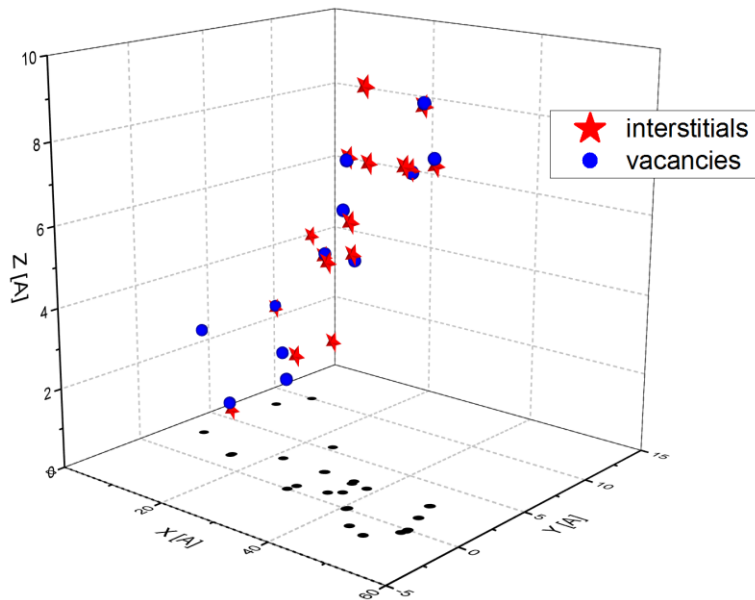
Kinchin-Pease: approximation

TCAS believed to be more reliable

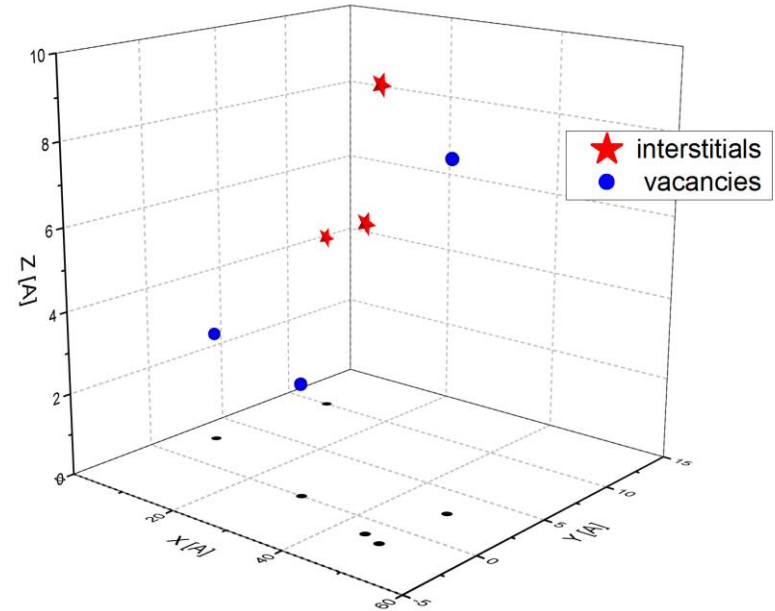


TCAS simulations 3D distributions

Example 1: $E_{si} = 1$ keV (max. recoil for $E_{el} = 3,5$ MeV)



16 V/I produced in cascade
Scale: x, y, z: 60, 20, 10 Å

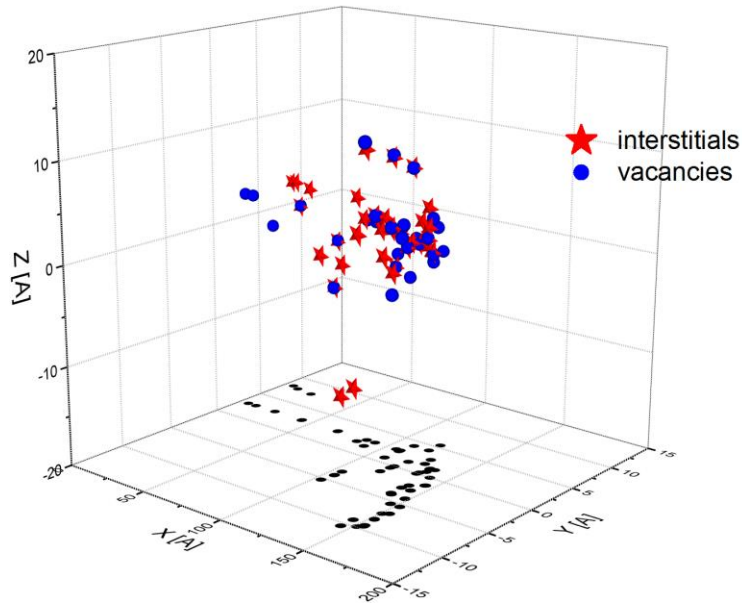


3 V/I after recombination (20%)

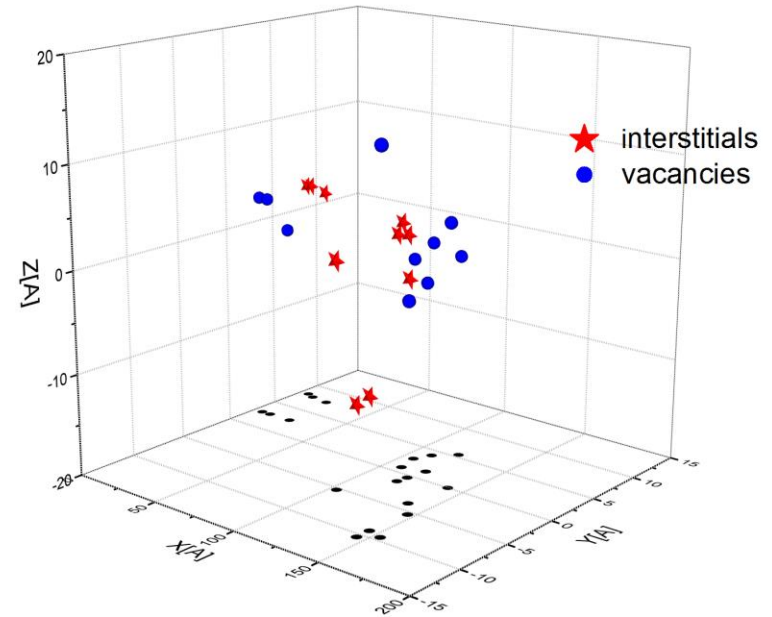
$R_{rec} = 4$ Angstrom (lattice constant: 5,43 Å)

TCAS simulations 3D distributions

Example 2: $E_{\text{Si}} = 3 \text{ keV}$ (max. recoil for $E_{\text{eI}} = 6 \text{ MeV}$)



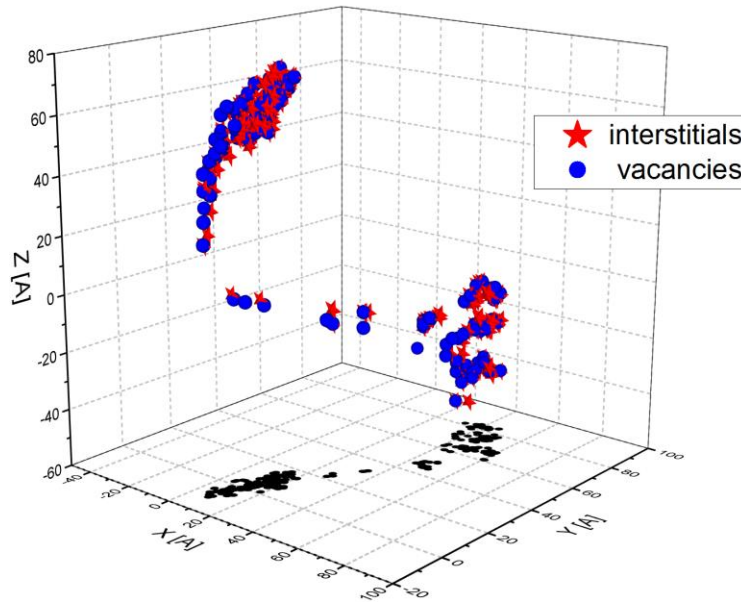
36 V/I produced in cascade
Scale: x, y, z: 200, 30, 40 Å



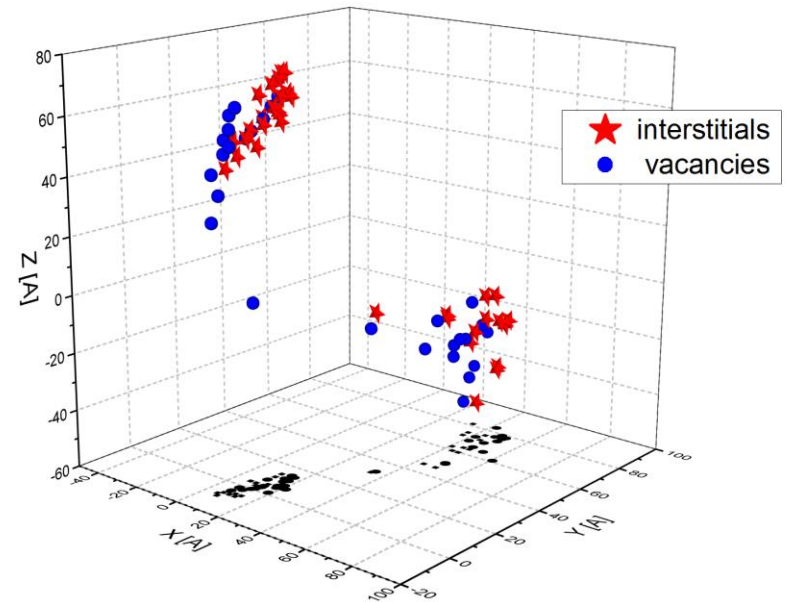
10 V/I after recombination (20%)

TCAS simulations 3D distributions

Example 3: $E_{si} = 20 \text{ keV}$ (max. recoil for $E_{el} = 15 \text{ MeV}$)



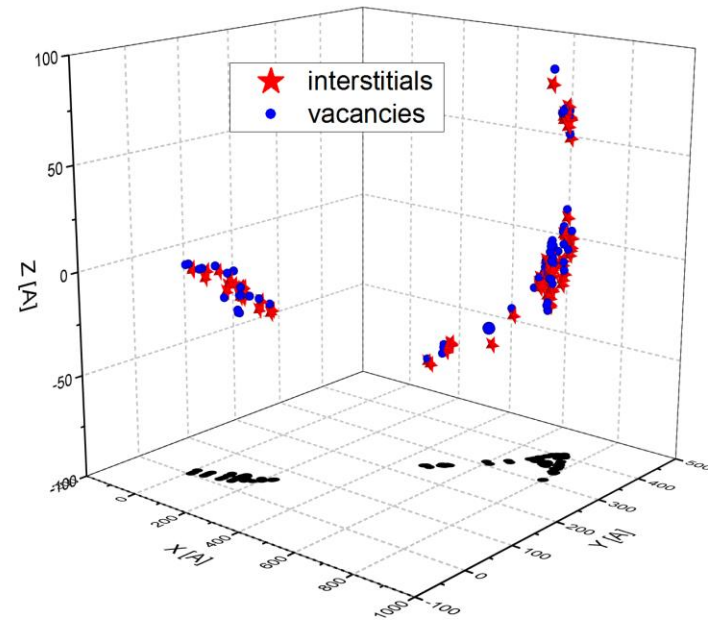
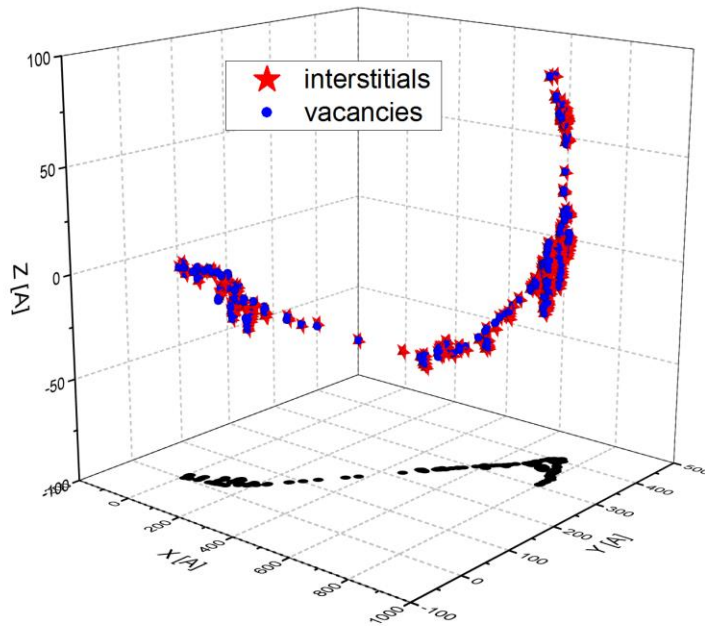
210 V/I produced in cascade
Scale: x, y, z: 150, 120, 140 Å



36 V/I after recombination (20%)

TCAS simulations 3D distributions

Example 3: $E_{si} = 60 \text{ keV}$ (max. recoil for $E_{e1} = 27 \text{ MeV}$)



474 V/I produced in cascade

86 V/I's after recombination (20%!)

X,y,z: 1200, 600, 200 Å

Attn: these are only examples for one ion each!
simulations done for 10 ions at each recoil energy

Random Walk of Defects

Contributed by Gregor

Procedure:

Input from TCAS (original cascade without intra-cascade recombination)

1. Correct for „doubles“, if so move V or I by one lattice distance
2. Do initial recombination of V-I, after that: $V+V \rightarrow V_2$ and $I+I \rightarrow I_2$
3. Start with the random walk:
 - a. Find minimum distance d between any two I or V.
 - b. Set “adaptive time step” according $t_{step} = \frac{d^2}{2 \cdot D_{V,I}}$
 - c. Move all defects with steps in x, y, z distributed randomly according to Gaussian with width given by $\sigma = \sqrt{2 \cdot D \cdot t_{step}}$
 - d. Loop over all defects and look for interactions. If two defects interact, create (or annihilate) a new defect with given properties and include it in the next step (parents \rightarrow child hierarchy)
 - e. Repeat from step a-e as many times as required

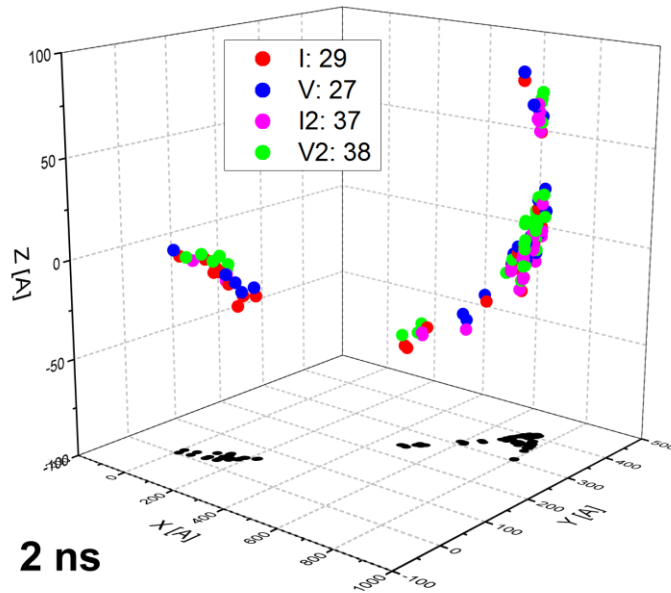
Assumptions

- Diffusion constants: S.M. Myers et al. JAP 104 (2008).
dependece on charge states neglected
- D assumed independent on lattice orientation
- Reaction occurs if two defects are within given radius at given time step - (ON/OFF) decision, will be improved to calculate probability based on distance. This is one of the most important improvements needed.

Software

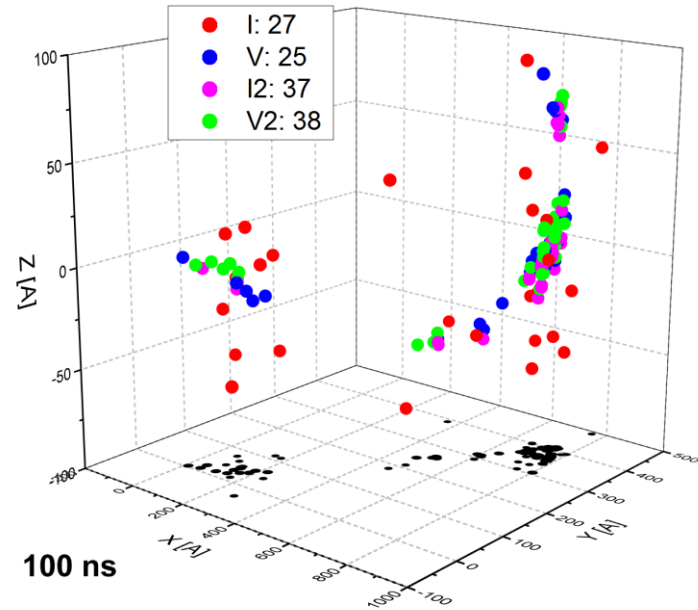
- TCAS for generation of V,I
- Random Walk is a c++ ROOT based library.
 - Inputs:
 - Table with interaction radii, $R_{VI} = 4 \text{ \AA}$, $R_{VV} = 7.7 \text{ \AA}$, $R_{II} = 7.9 \text{ \AA}$
 - Table with possible reactions, so far only: V+I, V+V, I+I
 - Diffusion constants, only for I and V, V_2 and I_2 assumed immobile
 - Visualization based on ROOT

Example: Si-recoil energy of 60 keV



2 ns

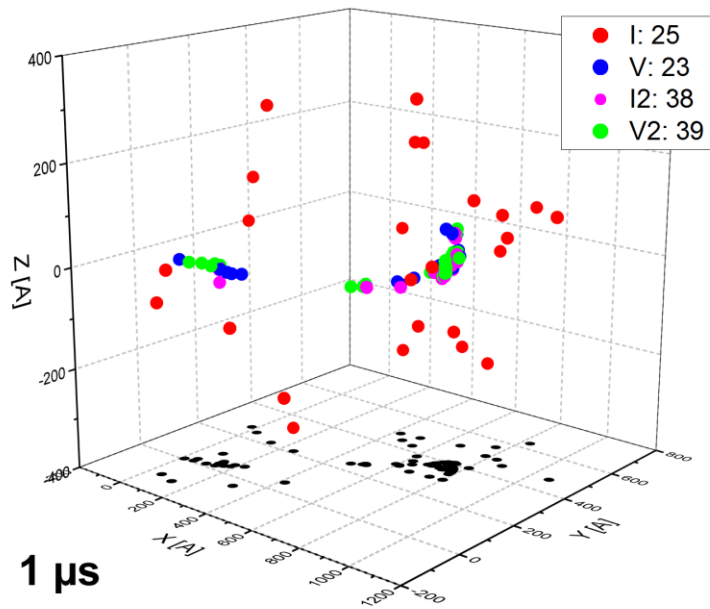
$t = 2$ ns: not much migrations yet,
a lot of I2 and V2 formed
in or close to initial cascade
Scale: x, y, z: 1200, 600, 200 Å



100 ns

$t = 100$ ns: I2 and V2 not much changed
I's migrate out of the initial
cascade
Scale: x, y, z: 1200, 600, 200 Å

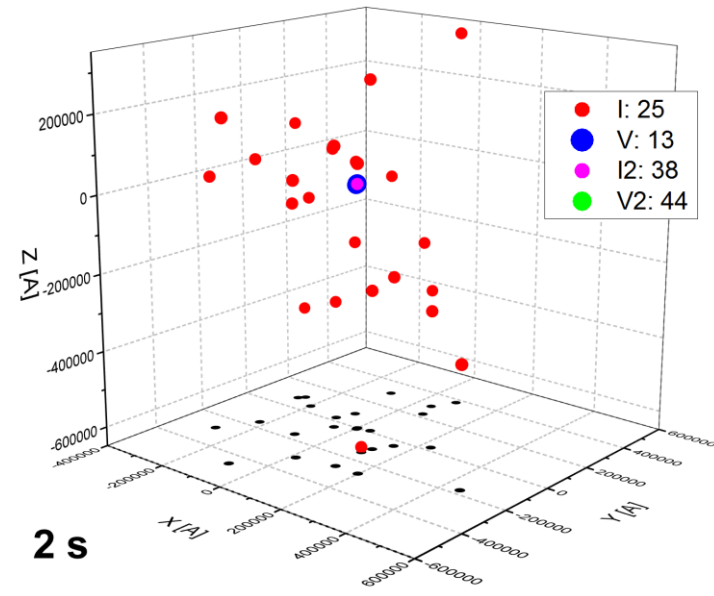
Example: Si-recoil energy of 60 keV



1 μs

$t = 1 \mu\text{s}$, original cascade still in place (I2, V2 assumed to be immobile), ongoing fast migration of I's

Scale: x, y, z: 1400, 1000, 1000 Å

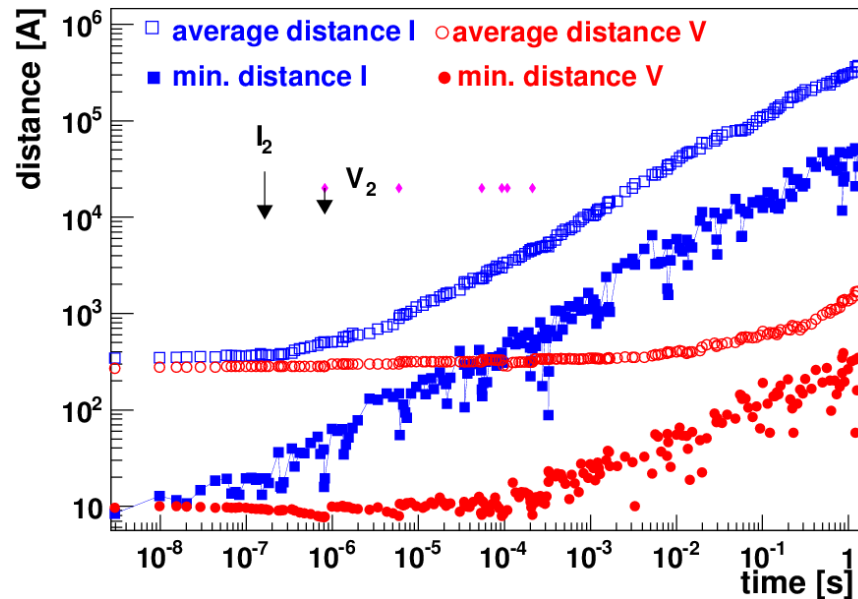


2 s

$t = 2 \text{ s}$, 25 of the initial 103 I's have moved throughout the detector volume! Finally: more V2 than I2 formed!

Scale: x, y, z: 100, 120, 100 μm !

Example: Si-recoil energy of 60 keV



At 1 s: average distance I: 32 μm!

At 1 s: average distance V: 0,14 μm!

Interstitials migrate much faster than vacancies,
hence they evade disordered regions more likely,
More V₂ than I₂ formed as seen for t > 1 μs

Conclusions and Outlook

- Mott scattering implemented from Lijians parameterization, be aware of simple textbook equations, especially for heavier atoms
- Partition function used from Akkermann and Jun, small deviations in displacement function due to atomic screening in Rutherford equation (Jun)
- Displacement function derived from TRIM and TCAS deviate from traditional approach, TCAS believed to be more reliable than TRIM
- TCAS offers simulation for single crystals (Si: $\langle 100 \rangle$) and a direct output for both vacancies and interstitials plus recombination within initial cascade, leaving 20% surviving for migration
- Random walk studies reproduce TCAS recombinations and show development of I, V, V-V and I-I as fct. of time. Interstitials move faster and hence evade damage sites especially seen after longer times (μs)
- TRIM and TCAS are binary code collision approximations, describing damage production as sequence of 2 body interactions (cascades)
- More realistic (?): MD model, based on many body interactions, local heating, melting, amorphization, recrystallisation taken into account, see C. Inguibert et al., IEEE NS 57, 4 (2010) and literature cited there
- Future approach: start with MD, followed by random walk as in this report

Kinchin-Pease approximation

Kinchin and R.S. Pease, The displacement of atoms in solids by radiation, Rep. Prog. Phys., vol. 18, p. 1, 1955

Describes number N_{FP} of produced Frenkel pairs for an energy E_{PKA} of a primary knock on atom by a simple analytic equation:

$$N_{FP} = 0.8 \cdot (E_{PKA} / 2T_{d,av}) \text{ for } E_{PKA} > 2T_{d,av} / 0.8$$

$T_{d,av}$: average displacement energy

This simple equation should be taken with great care, see one of the figures (slide 8) in this report. It is included in SRIM/TRIM as one of the options, does not describe TRIM nor TCAS results.

Molecular Dynamics Simulation

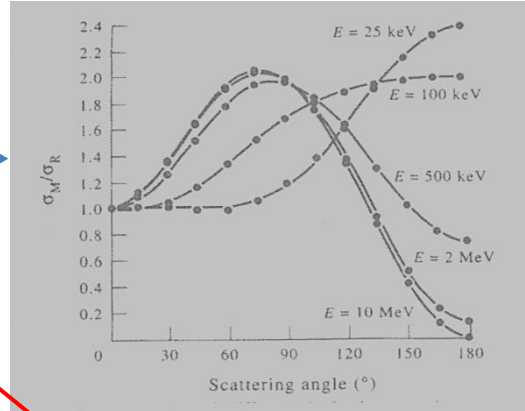
Based on many body interactions in contrast to BCA, binary code 2 body collisions, as in TRIM, TCAS.

- *In contrast to Kinchin-Pease non-linear effects primarily at low E_{PKA}*
- *Displacements can be generated even for $E_{PKA} < E_d$!*
- *Initially huge no of FP produced, cooling down to RT within few ps*
- *After stable condition reached (< 10 ps) no of FP roughly as in BCA*
- *Isolated point defects are predominantly interstitials (see Gregor)*
- *Amorphous clusters may be produced in cascade core*

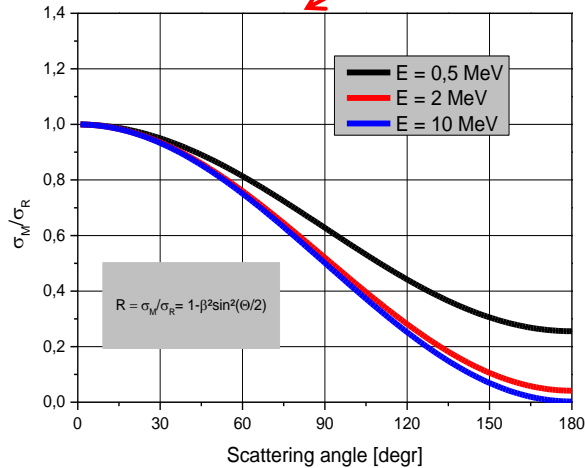
For further reading start with citations given in:

C. Inguibert et al: „Effective NIEL“ in Silicon: Calculation Using MolecularDynamics Simulation Results, IEEE NS Vol 57, No 4, 2010

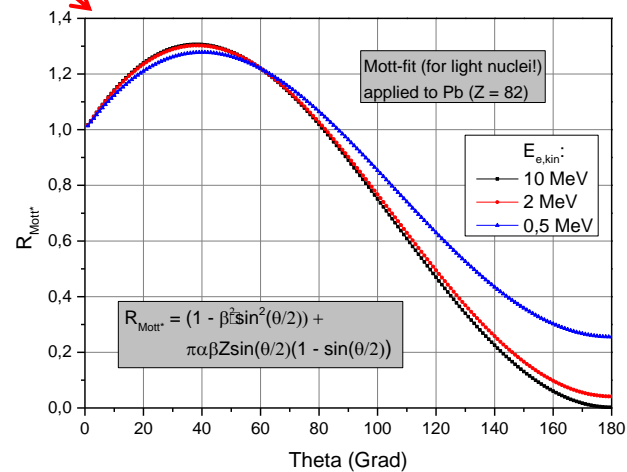
$\sigma_{\text{Mott}}/\sigma_{\text{Ruthf}}$ für Pb nach Lijian
 Punkte: exakte Mott-Formel
 Linien: Fit nach Lijian



Simple approaches don't work



Simple textbook equation
 $\pi\alpha Z \ll 1$; SI: $\pi\alpha Z = 0,3$!



Better approach for light nuclei